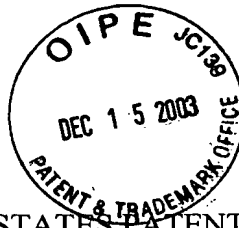


DOCKET NO: 210313US2SRD



IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
AKIRA NISHIYAMA, ET AL. : EXAMINER: MAI, A.
SERIAL NO: 09/891,129 :
RCE FILED: JUNE 6, 2003 : GROUP ART UNIT: 2814
FOR: SEMICONDUCTOR DEVICE :
HAVING AN INSULATING FILM MADE
OF A HIGHLY DIELECTRIC THIN FILM
AND METHOD OF MANUFACTURING
THE SAME

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action of August 15, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 7 of this paper.

Remarks begin on page 12 of this paper.